

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10042154	01/11/2002	516	077	1712	METZMAIER

**APPLICANTS: Ishitobi Ken; Kumita Tetsuro; Hon Kimihiro; Suzuki Yoshinori;

**CONTINUING DATA VERIFIED:
THIS APPLN CLAIMS BENEFIT OF 60/260,883 01/12/2001
AND A CIP OF PCT/JP01/05800 07/04/2001

** FOREIGN APPLICATIONS VERIFIED:
JAPAN 2000-204163 07/05/2000

PG: PUB DO NOT PUBLISH ☐

RESCIND ☐

Foreign priority claimed ☐ yes ☐ no
35 USC 119 conditions met ☐ yes ☐ no

ATTORNEY DOCKET NO

Q62628

TITLE : Polishing composition and magnetic recording disk substrate polished with the polishing composition

U.S. DEPT. OF COMM / PAT & TM-PTO-435L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.				

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)